



Contact for technical communication:

RNDR. JANA SKOPALOVÁ, PH.D.

E: jana.skopalova@upol.cz P: +420 585 634 442



Contact for business communication:

Mgr. ROMAN JUREČKA

E: rcptm.services@upol.cz P: +420 585 631 530



Regional Centre of Advanced Technologies and Materials

Šlechtitelů 27, 783 71 Olomouc Czech Republic

www.rcptm.com

P

WWW.RCPTM.COM

ATOMIC FORCE MICROSCOPY SECM



MAPPING OF THE ELECTRICAL, ELECTROCHEMICAL AND MECHANICAL PROPERTIES OF SURFACES





Palacký University Olomouc REGIONAL CENTRE OF ADVANCED TECHNOLOGIES AND MATERIALS





Palacký University Olomouc

ATOMIC FORCE MICROSCOPY SECM MAPPING OF THE ELECTRICAL, ELECTROCHEMICAL

AND MECHANICAL PROPERTIES OF SURFACES

 \checkmark

Bruker's Dimension Icon allows to track the topography of different types of samples in high-resolution while tracking other sample properties such as mechanical properties, conductivity, magnetic properties, or sensing the surface of the sample during the electrochemical process. The scanning electrochemical microscope in combination with the AFM allows the recording of electrochemical properties together with topography and mechanical properties at the same time, with a spatial resolution of less than 100 nm.



Dimension Icon with ScanAsyst (Bruker)

ACQUIRED INFROMATION

- > topography in nanoscale
- > nanomechanical properties adhesion, modulus, deformation
- > nanoelectrical properties conductivity, surface potential mapping
- > magnetic properties
- > electrochemistry in nanoscale

SAMPLE TYPES

- > insulators, semiconductors, conductors
- > biological and fragile materials
- > nanoparticles, nanofibres
- > maximum size: height 15 mm, diameter 210 mm (50 mm for electrochemistry)

MODES CONDITIONS AND PRECISION

- measuerements in contact mode, tapping mode and special PeakForce
 Tapping mode
- > measurements available on both air and liquid
- > maximal scan size 90 x 90 x 13 μ m
- > high resolution (noise: lateral ≤ 0.15 nm, vertical ≤ 35 pm RMS at closed-loop)
- > system is capable to perform:
 - o surface topography (AFM)
 - o quantitative nanomechanical properties (QNM)
 - o electrical properties (C-AFM, PF-TUNA, KPFM)
 - o magnetic properties (MFM)
 - o electrochemical AFM (EC-AFM)
 - o scanning electrochemical microscopy (SECM-AFM)



Surface potential of coin: silver (green), copper (red).





Image of nanomechanical properties of a blend of polystyrene and polyolefin elastomer measured on air. Adhesion (top), deformation (bottom).



Topography of syringe filter from celulose.



Topography of polycarbonate filter.



 \wedge